



Practitioner No. 081468-0306526
Client Reference: P-1598.010-US

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **ANTONIUS THEODORUS ANNA MARIA DERKSEN et al.**

Application No.: 10/705,785

Confirmation No.: 5221

Filed: November 12, 2003

Group No.: 2882

Examiner:

For: **LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD**

**Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

**SUPPLEMENTAL APPLICATION DATA SHEET
37 C.F.R. § 1.76(c)**

The following information on the Application Data Sheet is changed as indicated:

BIBLIOGRAPHIC DATA

1. Assignee information is being modified.

The assignee(s) of this application is/are:

ASML NETHERLANDS B.V.

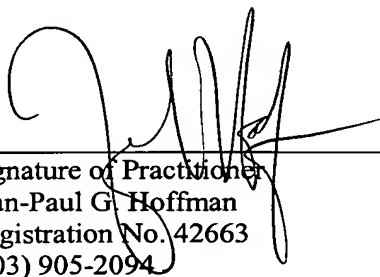
De Run 6501, NL-5504 DR Veldhoven, The Netherlands

Extent of interest of assignee in application: ENTIRE RIGHT, TITLE AND INTEREST

Date: June 22, 2004

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